MPI T53500–5E 300 mm Automated Probe System For accurate and reliable IV, CV, pulsed-IV, 1/f and RF and with WaferWallet[®] Option for Fully Automatic Measurements

FEATURES / BENEFITS

Designed for Variety of On-Wafer Applications

- Device Modeling DC-IV, DC-CV, Pulse-IV, ESD, 1/f
- + RF and mmW RF Setup from 26 GHz to 110 GHz & beyond
- Wafer Level Reliability for accurate stress- and measure conditions
- Drivers for leading test executive software suits

WaferWallet® Option

- Designed with five individual trays for manual, ergonomic loading of 150, 200, or 300 mm "modeling" wafers
- Fully-automated tests with up to five identical wafers at multiple temperatures
- Unique capability to load/unload wafers at any temperature

MPI ShielDEnvironment[™] for Accurate Measurements

- Advanced EMI / RFI / Light-tight Shielding for best 1/f
 noise test results
- Ultra-low noise IV measurements down to fA level
- Programmable microscope movements for test automation and ease of use
- Wide temperature range -60 °C to 300 °C with unique configuration flexibility

Ergonomic Design and Options

- Easy wafer or single DUT loading from the front
- Integrated active vibration isolation
- Completely integrated prober control for faster, safer and convenient system and test operation
- The Safety Test Management (STM[™]) with automated dew point control
- Reduced footprint due to smart integration of the chiller
- Instrument shelf option for shorter RF cables providing the highest measurement dynamic

STAGE SPECIFICATIONS

Chuck XY Stage (Programmable)

Travel range	310 mm x 530 mm (12.2 x 20.87 in)
Resolution	0.5 μm
Accuracy	< 2.0 μm (0.08 mils)
Repeatability	< 1.0 μm
XY stage drive	Closed-loop high precision stepper motors
Speed*	Slowest: 10 μm / sec Fastest: 50 mm / sec



30 mm (1.18 in)
0.2 μm
< 2.0 µm
< 1.0 µm
Closed-loop high precision stepper motor
Slowest: 10 μm / sec Fastest: 20 mm / sec
Precision ball bearings

Chuck Z Stage (Programmable)

*The speed is instantaneous speed, not average speed. There is accelerate and decelerate time when moving.

STAGE SPECIFICATIONS

Chuck Theta Stage (Programmable)		
Travel range	± 5.0°	
Resolution	0.0001° (0.24 μm @ 300mm edge)	
Accuracy	$<$ 2.0 μm (measured at the edge of the 300 mm chuck)	
Repeatabilty	< 1.0 μm	
Theta stage drive	High resolution stepper motor with linear encoder feedback system	

PROBE PLATEN

Specifications

-	
Material	STD: Nickel plated steel / LTM: Dedicated high-thermal stable, Ni plated
Chuck to ShielDGuard height	min. 5 mm
Platen cooling	Fully integrated CDA cooling, by using the chiller CDA
Configuration	Probe card holder 4.5 x 7" and/or MicroPositioners
Max. No. of MicroPositioners	8x DC MicroPositioners or 4x DC + 4x RF MicroPositioner Setup
RF MicroPositioner mounting	Magnetic with guided rail
DC MicroPositioner mounting	Magnetic





Large Probe Platen supporting up to 8x DC or 4x DC + 4x RF MicroPositioners or standard 4.5" probe card holder

ShielDEnvironment™

MPI ShielDEnvironment[™] is a high performance local environmental chamber providing excellent EMI- and light-tight shielded test environment for ultra-low noise, low capacitance measurements.

MPI ShielDEnvironment[™] allows for testing with up to 4-port RF or up to 8-ports DC/Kelvin or a combination of those configurations. MPI ShielDCap[™] provides easy reconfiguration of measurement setup as well as EMI/noise shielding - These all makes a great difference to conventional systems, especially in a day-to-day operation.

-	ShielDEnvironment [™] Electrical Specifications [*]		
	EMI shielding	> 30 dB (typical) @ 1 kHz to 20 GHz	
	Light attenuation	≥ 130 dB	
	Spectral noise floor	≤ -180 dBVrms/rtHz (≤ 1 MHz)	
	System AC noise	≤5 mVp-p (≤1 GHz)	

*Including 4 MicroPositioners.



MPI NoiseShield™ OPTION FOR 1/f (FLICKER) & RTN MEASUREMENTS

MPI's exclusive NoiseShield[™] offers in combination with MPI ShielDEnvironment[™] for unsurpassed active EMI-Shielding of DUT and the measurement instrument (such as pre-amplifier unit). In addition, it provides all cables and connectors close to DUT.

The **NoiseShield™** option provides shortest possible cable lengths to reduce parasitic capacitance and to maximize test system roll-off frequency. It reduces external magnetic field influences on the measurement results and makes the 1/f, RTN Setup more robust and test lab location less independent.

Low impedance cables (for DC or RF pad design), excellent low-impedance system's grounding and ferrite cores on the unique MPI Kelvin probes are part of the delivery in order to make the probe station completely "invisible" and the measurement results to reach the limit of the instrumentation.



AUTOMATED TEST OVER MULTIPLE TEMPERATURES ATMT™

True to our mission of making complex probe station operation as intuitive as possible, minimizing training costs, and continuously focusing on reducing cost of test, MPI designed unique and cost-effective technologies, that enable Automated Test over Multiple Temperatures ATMT[™]. In combination with MPI's WaferWallet[®] or WaferWallet[®]MAX, Device Modeling and Wafer Level Reliability engineers will benefit from these features to generate significant more measurement data and will increase the entire Test Cell efficiency.



Celadon, high-performance, low-leakage probe cards



MPI Kelvin LTM high temperature probe arms



RF LTM probe arms, equipped with SmartCarrier™

ATMT[™] DC

For DC over temperature measurements, Device Modeling and Wafer Level Reliability engineers are commonly using Celadon's, high temperature, low leakage probe cards. MPI and Celadon are finally offering leading edge, complete measurement solutions, enabling Automated Test over Multiple Temperatures ATMT[™] DC at wide temperature range: -60...300°C. For the case of a few measurements performed with MicroPositioners, MPI has developed thermally stable Kelvin LTM probes that allow Automated Test over Multiple Temperatures ATMT[™] at -40 to 175°C.

ATMT[™] RF

MPI's SmartCarrier[™] uniquely combines different materials that automatically compensate for the lateral expansions of the RF probes and the wafer without the need for complex software or programmable MicroPositioners^{*}.

SENTIO[®]'s new patent-pending ContactSense[™] image processing can determine the new contact positions on-the-fly with an accuracy of a few micrometers, completing MPI's Automated Test over Multiple Temperatures ATMT[™] RF.

*One programmable MicroPositioner is recommended for automated RF calibration by using QAlibria®

WAFER LOADING

Loading or unloading of 150, 200 or 300 mm wafers or substrates is straight forward and intuitive. Special design of the chuck provides easy loading of a single IC of wafer fragments from the system front. SmartVacuum[™] technology automatically recognizes size of the wafer on single IC. It also protects the wafer from unexpected release of vacuum due to inexperienced operation when the wafer is located in the IceFreeEnvironment[™]. Easy access to the AUX chucks serves for quick exchange of RF calibration substrates, probe cleaning and plana-

rization accessories.



AUTOMATED WAFER LOADING OPTIONS

WaferWallet®



Wafer loading trays	5
Supported wafer sizes	150, 200, or 300 mm
Individual notch marks	0, 90, 180 & 270 deg for all wafer sizes
Hot and cold wafer swapping	Yes, local environmental chamber
Wafer pre-aligner	For 150, 200 and 300 mm, option
Wafer ID-Reader	Option for top or bottom ID reading Revolutionary integrated RGB illumination Fully automatic exposure control Code shift compensation OCR, Barcode, DataMatrix and QR code
Signal light tower	Four color, LED steady/flashing tower lights

WaferWallet®MAX



WaferWallet®ULTRA



Number of cassettes	1
Cassette type	Semi Standard, opened
Supported wafer sizes	150, 200 or 300 mm FOUP/FOSB Semi standard opened cassette
Wafer pre-aligner	Included
Cassette scanner	Included
Wafer ID-Reader	Option for top or bottom ID reading Revolutionary integrated RGB illumination Fully automatic exposure control Code shift compensation OCR, Barcode, DataMatrix and QR code
Signal light tower	Four color, LED steady / flashing tower lights

Load port	300 mm with automated door opener
Supported wafer size	300 mm FOUP cassette, 200 mm with insert adapter
Wafer pre-aligner	Included
Cassette scanner	Included
Wafer ID-Reader	Option for top or bottom ID reading Revolutionary integrated RGB illumination Fully automatic exposure control Code shift compensation OCR, Barcode, DataMatrix and QR code
Signal light tower	Four color, LED steady/flashing tower lights

Probe Hover Control™

MPI Probe Hover Control PHC[™] allows easy manual control of probe contact and separation to wafer. Separation distance can accurately control with micrometer feedback for probe to wafer/pad positioning. Ease of use guarantees the safest operation by minimizing error during critical setup and probe change operations.

THERMAL CHILLER INTEGRATION

Minimized CDA Consumption

The CDA consumption is reduced by as much as 50% by purging IceFreeEnvironment[™] with the reused cold air of the chiller. Additional automated valve enables purge by Nitrogen*.

Additionally, recycled CDA cools the system probe platen and the probe card.

*ERS patented technology.





Picture is courteously provided by ERS.

INTEGRATED CONTROLS

Thermal chuck touchscreen control display is an alternative way of interaction with the thermal system. Its ergonomic location supports an operator when keying commands and monitoring system status. The fully integrated intelligent hardware control panel is design for intuitive and safe system control and operation. All these significantly increase the speed and improve convenience of the system interaction work flow.

The keyboard and mouse are placed on the sliding tray right below the system control panel. Both can control test instrumentation, if required.

USB port is also in front of the system. It removes any hassles when exchanging data.







SOFTWARE SOLUTION

Unique and revolutionary multi-touch operation software SENTIO[®] controls MPI automated engineering probe systems. Its simple and intuitive operation concept significantly saves operator training time. Scroll, Zoon, and Move functions mimic modern smart mobile device interface. Switching between applications is just a matter of a simple finger swipe.

SENTIO[®] makes everyone the system operation expert in just minutes.

MICROSCOPE MOVEMENT

XYZ Programmable

XY - Travel range*	50 x 50 mm / 300 x 300 mm
Resolution	1 μm (0.04 mils)
Repeatability	≤ 2 µm (0.08 mils)
Accuracy	≤ 5 µm (0.2 mils)
Z - Travel range	140 mm
Resolution	0.05 μm (0.002 mils)
Repeatability	≤ 2 µm (0.08 mils)
Accuracy	≤ 4 µm (0.16 mils)

*In case of ShielDEnvironment™X x Y: 25 mm x 25 mm

By implementing intuitive multi-touch operation, QAlibria[®] provides crisp and clear guidance to the RF calibration process, minimizes configuration mistakes and helps to reach accurate calibration results in fastest time. QAlibria[®] offers industry standard and advanced calibration methods.

QAlibria[®] includes TOSM (SOLT), TMR, TMRR methods, and 4-port calibration capability additionally to the integration of NIST StatistiCal calibration packages providing easy access to the NIST multiline TRL metrology-level calibration and uncertain analysis.





READY FOR THE TEST[™]

TYPICAL CONFIGURATION WITH MPI KELVIN AND MPI KELVIN-HIGH TEMPERATRUE PROBES INSIDE ShielDEnvironment[™]

	Coax Probe	Triax Probe	Kelvin Probe	Kelvin HT Probe
Max voltage	500 V	500 V	500 V	500 V
Temperature range	-60 °C to 300 °C	-60 °C to 300 °C	-60 °C to 200 °C	-60 °C to 200 / 300 °C
Leakage current	< 0.8 pA	< ± 20fA	< ± 10fA	<±10fA /<±20fA
Connectivity	SMB / BNC	Standard Triax	Kelvin Triax	Kelvin Triax
Connectivity type	Single, Coaxial	Single, low noise Trixial	Force / low nois	' Sense, e Triaxial
Characteristics impedance	50 Ohms	50 Ohms	50 Ohms	50 Ohms
Residual capacitance	< 95 fF	< 95 fF	< 95 fF	< 95 fF
Probe holder material	Au-plated Brass		Au-plated Bras (Guarded)	
Probe tip type	Variety of metal tips		Coaxial / Guarded	Guarded ceramic blades
Probe tips material	W, BeCu, Au-plated		W	WRe
Probe tips radius	0.5 μm – 25 μm	0.5 μm – 25 μm	0.5 μm – 5 μm	2 μm – 5 μm
Minimum pad size	25 μm x 25 μm	25 μm x 25 μm	30 µm x 30 µm	25 μm x 25 μm





Typical MPI configuration with Kelvin Probes



NON-THERMAL CHUCKS

Standard	Triaxial
Coax BNC (f)	Kelvin Triax (f)
310 mm with 2 integrated AUX areas	
Nickel plated aluminum (flat with 0.	5 mm holes)
Planar with 0.5 mm diameter holes i	n centric sections
4, 24, 48, 72, 96, 120, 144, 168, 192, 2	16, 240, 264, 288 mm
In front for single DUT 5x5 mm (4 ho In center for 150, 200, 300 mm (6, 8,	les) and 75 mm (3 in) 12 in)
≤±5μm**	
< 15 µm / 10 N @edge	
	Standard Coax BNC (f) 310 mm with 2 integrated AUX areas Nickel plated aluminum (flat with 0. Planar with 0.5 mm diameter holes i 4, 24, 48, 72, 96, 120, 144, 168, 192, 2 In front for single DUT 5x5 mm (4 ho In center for 150, 200, 300 mm (6, 8, $\leq \pm 5 \mu \text{m}^{**}$ $< 15 \mu \text{m} / 10 \text{ N}$ @edge

*Single DUT testing requires higher vacuum conditions dependent upon testing application. **By using SENTIO® topography

Triaxial RF Wafer Chuck			
Connectivity	Kelvin Triax (f)		
Diameter	310 mm with 2 integrated AUX chucks		
Material	Nickel plated aluminum (flat with 0.5 mm holes)		
Chuck surface	Planar with 0.5 mm diameter holes in centric sections		
Vacuum holes sections (diameter)	4, 24, 48, 72, 96, 120, 144, 168, 192, 216, 240, 264, 288 mm		
SmartVacuum [™] distribution	In front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) In center for 150, 200, 300 mm (6, 8, 12 in)		
Surface planarity	≤±5μm**		
Rigidity	< 15 µm / 10 N @edge		

*Single DUT testing requires higher vacuum conditions dependent upon testing application. **By using SENTIO® topography

Auxiliary Chuck	
Quantity	2 AUX chucks
Position	Integrated to front side of main chuck
Substrate size (W x L)	Max. 25 x 25 mm (1 x 1 in)
Material	Ceramic, RF absorbing material for accurate calibration
Surface planarity	≤±5μm
Vacuum control	Controlled independently, separate from chucks
Electrical Specification (Coax)	
Operation voltage	In accordance with EC 61010, certificates for higher voltages available upon request
Maximum voltage between chuck top and GND	500 V DC
Isolation	> 2 GΩ
Electrical Specification (Triax)	
Chuck Isolation	At 10 V
Force-to-Guard	> 5 T Ohm
Guard-to-Shield	> 1 T Ohm
Force-to-Shield	> 5 T Ohm

THERMAL CHUCKS

Specifications of MPI ERS AirCool® PRIME Technology

	Ambient to 200/300 °C	20 °C to 200/300 °C	Ambient to 200/300 °C	20 °C to 200/300 °C	
Chuck type	RF RF Ultra low noise Ultra low noi			Ultra low noise	
Connectivity	Kelvin Triax (f)	Kelvin Triax (f)	Kelvin Triax (f)	Kelvin Triax (f)	
Temperature control method	Cooling air / Resistance heater	Cooling air / Resistance heater	Cooling air / Resistance heater	Cooling air / Resistance heater	
Coolant	Air (user supplied)	Air (user supplied)	Air (user supplied)	Air (user supplied)	
Smallest temperature selection step	0.1 °C	0.1 °C	0.1 °C	0.1 °C	
Chuck temperature display resolution	0.01 °C	0.01 °C	0.01 °C	0.01 °C	
External touchscreen display operation	Yes	Yes	Yes	Yes	
Temperature stability	±0.08 °C	±0.08 °C	±0.08 °C	±0.08 °C	
Temperature accuracy	±0.1 °C	0.1 °C	0.1 °C	0.1 °C	
Control method	Low noise DC/PID	Low noise DC/PID	Low noise DC/PID	Low noise DC/PID	
Chuck pinhole surface plating: 200°C / 300°C	Nickel / Gold	Nickel / Gold	Nickel / Gold	Nickel / Gold	
SmartVacuum™ distribution	In front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) In center for 150, 200, 300 mm (6, 8, 12 in)				
Temperature sensor	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	
Temperature uniformity	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	
Surface flatness and base parallelism	< ±12 µm	< ±12 µm	< ±12 µm	< ±12 μm	
Max. Voltage between					
Force-to-GND	600 V DC	600 V DC	600 V DC	600 V DC	
Force-to-Guard	100 V DC	100 V DC	600 V DC	600 V DC	
Guard-to-GND	400 V DC	400 V DC	400 V DC	400 V DC	
Heating rates*	35 to 200 °C < 16 min 35 to 300 °C < 29 min	20 to 200 °C < 19 min 20 to 300 °C < 30 min	35 to 200 °C < 17 min 35 to 300 °C < 33 min	20 to 200 °C < 21 min 20 to 300 °C < 34 min	
Cooling rates*	200 to 35 °C < 24 min 300 to 35 °C < 27 min	200 to 20 °C < 35 min 300 to 20 °C < 42 min	200 to 35 °C < 27 min 300 to 35 °C < 31 min	200 to 20 °C < 37 min 300 to 20 °C < 50 min	
Leakage @ 10 V	N/A	N/A	< 15 fA at 25 °C < 30 fA at 200 °C < 50 fA at 300 °C	< 15 fA at 25 °C < 30 fA at 200 °C < 50 fA at 300 °C	
Electrical isolation	> 5 T Ω at 25 °C > 1 T Ω at 200 °C > 0.5 T Ω at 300 °C	> 5 T Ω at 25 °C > 1 T Ω at 200 °C > 0.5 T Ω at 300 °C	N/A	N/A	
Capacitance					
Force-to-Guard	< 1600 pF	< 1600 pF	< 600 pF	< 600 pF	
Guard-to-Shield	< 2000 pF	< 2000 pF	< 2000 pF	< 2000 pF	

*Typical data for all chucks based on FPS requirements.

Specifications of MPI ERS AirCool® PRIME with Fusion Chiller Technology 🃦

Chuck typeRFRFRFConnectivityKelvin Triax (f)Kelvin Triax (f)Kelvin Triax (f)Image: transmission of traix (f)Resistance heaterResistance heaterResistance heaterCooling air / Resistance heaterCooling air / Resistance heaterCooling air / Resistance heaterCooling air / Resistance heaterCoulantAir (user supplied)Air (user supplied)Air (user supplied)Air (user supplied)Smallest temperature selection step0.1 °C0.1 °C0.1 °CChuck temperature display presolution0.01 °C0.01 °C0.01 °CExternal touchscreen display presolutionYesYesYesTemperature accuracy0.1 °C0.1 °C0.01 °CControl methodCoole soc DC/PIDLow noise DC/PIDLow noise DC/PIDInterfaces plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldInterfaces plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldInterfaces plating: 200°C / 300°CSich S'C at s 200 °C < st 200 °C<			-10 °C to 200/300 °C	-40 °C to 200/300 °C	-60 °C to 200/300 °C
ConnectivityKelvin Triax (f)Kelvin Triax (f)Kelvin Triax (f)Kelvin Triax (f)Kelvin Triax (f)Cooling air / Resistance heaterCooling air / Resistance heater	Chuck type		RF	RF	RF
Temperature control method Cooling air / Resistance heater Cooling air / Resistance heater Cooling air / Resistance heater Cooling air / Resistance heater Coolant Air (user supplied) Air (user supplied) Air (user supplied) Air (user supplied) Smallest temperature selection step 0.1 °C 0.1 °C 0.1 °C 0.1 °C Chuck temperature display operation 0.01 °C 0.01 °C 0.01 °C 0.01 °C Etermal touchscreen display operation Yes ¥es ¥es ¥es Temperature accuracy 0.1 °C 0.1 °C 0.0 °C 0.0 °C Control method Low noise DC/PID Low noise DC/PID Low noise DC/PID Non noise DC/PID Interfaces RS232C RS232C RS232C RS232C Chuck pinhole surface plating: 200°C / 300°C Nickel / Gold Nickel / Gold Nickel / Gold Smart Vacuum™ distribution In front for single DUT Sx5 mm (4 holes) and 75 mm (3 in) In center for 150, 200 and 300 mm (6, 8, 12 in) Pt100 1/3DIN, 4-line wired Sto 5 °C 3 coo °C < at 200 °C < a	Connectivity		Kelvin Triax (f)	Kelvin Triax (f)	Kelvin Triax (f)
CoolantAir (user supplied)Air (user supplied)Air (user supplied)Smallest temperature selection step0.1 °C0.1 °C0.1 °CChuck temperature display resolution0.01 °C0.01 °C0.01 °CChuck temperature stability10.08 °C40.08 °C40.08 °CTemperature scuracy0.1 °C0.1 °C0.1 °CControl methodLow noise DC/PIDLow noise DC/PIDLow noise DC/PIDInterfacesRS232CRS232CRS232CChuck temperature scuracyNickel / GoldNickel / GoldNickel / GoldInterfacesRS232CRS232CRS232CChuck pinhole surfaceNickel / GoldNickel / GoldNickel / GoldImperature sensorPt100 1/3DIN, 1 n center fur 50, 200 and 300 mm (6, 51 zi n) In center fur 50, 200 and 300 mm (6, 51 zi n) In center fur 50, 200 and 300 mm (6, 51 zi n)Surface flatness and sease parallelism< $\pm 12 \mu$ m< $\pm 12 \mu$ mAt Votage betweer< $\pm 0.00 VDC$ < $\pm 0.00 VDC$ Force to-GND600 VDC600 VDC600 VDCForce to-GND600 VDC600 VDC< $\pm 0.00 VDC$ Advite are string rates* $\pm 12 \mu$ m< $\pm 12 \mu$ m25°C-100 to 25°C <3 min	Temperature cont	rol method	Cooling air / Resistance heater	Cooling air / Resistance heater	Cooling air / Resistance heater
Smallest temperature selection step0.1 °C0.1 °C0.1 °C0.1 °CChuck temperature display resolution0.01 °C0.01 °C0.01 °C0.01 °CExternal touchscreer display operationYesYesYesTemperature stability±0.08 °C±0.08 °C±0.08 °CTemperature stability±0.08 °C0.1 °C0.1 °CControl methodLow noise DC/PIDLow noise DC/PIDLow noise DC/PIDInterfacesR5232CR5232CR5232CChuck pinhole surface plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldTemperature sensorPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredTemperature uniformity<±0.5 °C at ≤200 °C < <±1 °C at > 200 °C<±0.5 °C at ≤ 200 °C <±1 °C at > 200 °C<±10 °C at ≤ 200 °C <±1 °C at > 200 °CSurface flatness and base parallelism<±12 µm <±12 µm	Coolant		Air (user supplied)	Air (user supplied)	Air (user supplied)
Chuck temperature display operation0.01 °C0.01 °C0.01 °CExternal touchscreen tesplay operationYesYesYesTemperature stability±0.08 °C±0.08 °C±0.08 °CTemperature stability±0.08 °C0.1 °C0.1 °CControl methodLow noise DC/PIDLow noise DC/PIDLow noise DC/PIDInterfacesRS232CRS232CRS232CChuck pinhole surface placing: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldInterfacesNickel / GoldNickel / GoldNickel / GoldNickel / GoldImperature sensorPt100 1/3DIN, 1 n center 150, 200 °CPt100 1/3DIN, 4 line wiredPt100 1/3DIN, 4 line wiredImperature sensorPt100 1/3DIN, 	Smallest temperat selection step	ture	0.1 °C	0.1 °C	0.1 °C
External touchscreen display operationYesYesYesdisplay operation $\pm 0.08 ^\circ C$ $\pm 0.08 ^\circ C$ $\pm 0.08 ^\circ C$ Temperature scauracy $0.1 ^\circ C$ $0.1 ^\circ C$ $0.1 ^\circ C$ Control methodLow noise DC/PIDLow noise DC/PIDLow noise DC/PIDInterfacesRS232CRS232CRS232CChuck pinhole surface plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldSmartVacuum™ distributionIn front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) In center for 150, 200 and 300 mm (6, 8, 12 in)Temperature sensorPH00 1/3DIN, 4-line wiredPH100 1/3DIN, 4-line wiredTemperature uniformity $\leq \pm 0.5 ^\circ C at \leq 200 ^\circ C$ $< \pm 1 ^\circ C at > 200 ^\circ C$ $\leq \pm 0.5 ^\circ C at \leq 200 ^\circ C$ Surface flatness and between $\leq \pm 12 \mu m$ $\leq \pm 12 \mu m$ $\leq \pm 12 \mu m$ Force-to-GNDG00 V DCG00 V DC600 V DCGuard-to-GND400 V DC400 V DC400 V DCAc3 mg car	Chuck temperatur display resolution	e	0.01 °C	0.01 °C	0.01 °C
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Temperature accuract0.1 °C0.1 °C0.1 °CControl methodLow noise DC/PIDLow noise DC/PIDLow noise DC/PIDInterfacesRS232CRS232CRS232CChuck pinhole surface plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldSmartVacuum™ distributionIn front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) in center for 150, 200 and 300 mm (6, 8, 12 in)Pt100 1/3DIN, 4-line wiredTemperature sensorPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredTemperature uniformity<±0.5 °C at < 200 °C <±1 °C at > 200 °C<±0.5 °C at < 200 °C <±1 °C at > 200 °C<±0.5 °C at < 200 °C <±1 °C at > 200 °CSurface flatness and seg parallelism<±12 µm <±12 µm	Temperature stabi	ility	±0.08 °C	±0.08 °C	±0.08 °C
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InterfacesRS232CRS232CRS232CRS232CChuck pinhole surface plating: 200°C / 300°CNickel / GoldNickel / GoldNickel / GoldSmartVacuum™ distributionIn front for singe bUT 5x5 mm (4 holes) and 75 mm (3 in) In center 150, 200 and 300 mm (6, 8, 12 in)Pt100 1/3DIN, Pt100 1/3DIN,Pt100 1/3DIN, Pt100 1/3DIN,T=mperature uniformity< 40.5 °C at 200 °C < 41 °C at 200 °C < 400 VDC 400 VDC 	Control method		Low noise DC/PID	Low noise DC/PID	Low noiseDC/PID
$ \begin{array}{c c c c c c } \label{eq:constraint} \begin{tabular}{l c c c c } \label{eq:constraint} \begin{tabular}{l c c c c c c } \label{eq:constraint} \begin{tabular}{l c c c c c c c c c c } \label{eq:constraint} \begin{tabular}{l c c c c c c c c c c c c c c c } \label{eq:constraint} \begin{tabular}{l c c c c c c c c c c c c c c c c c c c$	Interfaces		RS232C	RS232C	RS232C
SmartVacuum [™] distributionIn front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) In center for 150, 200 and 300 mm (6, 8, 12 in) In center for 150, 200 and 300 mm (6, 8, 12 in)Temperature sensorPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredTemperature uniformity<±0.5 °C at < 200 °C <±1 °C at > 200 °C<±0.5 °C at < 200 °C <±1 °C at > 200 °CSurface flatness and base parallelism<±12 µm	Chuck pinhole sur plating: 200°C / 30	face 0°C	Nickel / Gold	Nickel / Gold	Nickel / Gold
First sensorPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredPt100 1/3DIN, 4-line wiredFirst set sensor $< \pm 0.5 \ C at \le 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C < 200 \ C < < \pm 1 \ C at > 200 \ C < < \pm 1 \ C at > 200 \ C \ C < = 200 \ C \ C \ C \ C \ C \ C \ C \ C \ C \$	SmartVacuum™ di	stribution	In front for singl In center fo	e DUT 5x5 mm (4 holes) and or 150, 200 and 300 mm (6, 8	l 75 mm (3 in) 3, 12 in)
$\begin{tabular}{ c $	Temperature sense	or	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired
Surface flatness andstate $< \pm 12 \ \mu m$	Temperature unifo	ormity	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C
Hax. Voltage betweining Force-to-GND 600 V DC 600 V DC 600 V DC Force-to-Guard 100 V DC 100 V DC 100 V DC Guard-to-GND 400 V DC 400 V DC 400 V DC Guard-to-GND 400 V DC 400 V DC 400 V DC Force-to-Guard -10 to 25 °C < 3 min	Surface flatness ar base parallelism	nd	< ±12 µm	<±12 μm	< ±12 µm
Force-to-GND $600 \ V \ DC$ $600 \ V \ DC$ $100 \ V \ DC$ Force-to-Guard $100 \ V \ DC$ $100 \ V \ DC$ $100 \ V \ DC$ Guard-to-GND $400 \ V \ DC$ $400 \ V \ DC$ $400 \ V \ DC$ Heating rates* $25 \ ^{\circ}C$ $-10 \ to \ 25 \ ^{\circ}C < 3 \ min$ $-40 \ to \ 25 \ ^{\circ}C < 5 \ min$ $-60 \ to \ 25 \ ^{\circ}C < 6 \ min$ $200 \ ^{\circ}C$ $-10 \ to \ 25 \ ^{\circ}C < 3 \ min$ $-40 \ to \ 25 \ ^{\circ}C < 5 \ min$ $-60 \ to \ 25 \ ^{\circ}C < 6 \ min$ $200 \ ^{\circ}C$ $-10 \ to \ 25 \ ^{\circ}C < 3 \ min$ $-40 \ to \ 25 \ ^{\circ}C < 5 \ min$ $-60 \ to \ 25 \ ^{\circ}C < 6 \ min$ $300 \ ^{\circ}C$ $25 \ to \ 300 \ ^{\circ}C < 28 \ min$ $-60 \ to \ 25 \ ^{\circ}C < 6 \ min$ $200 \ ^{\circ}C$ $300 \ ^{\circ}C < 20 \ to \ 25 \ ^{\circ}C < 26 \ min$ $300 \ to \ 25 \ ^{\circ}C < 24 \ min$ AC3 Mode $300 \ ^{\circ}C$ $200 \ to \ 25 \ ^{\circ}C < 21 \ min$ $200 \ to \ 25 \ ^{\circ}C < 22 \ min$ $200 \ ^{\circ}C$ $200 \ to \ 25 \ ^{\circ}C < 11 \ min$ $25 \ to \ -40 \ ^{\circ}C < 18 \ min$ $25 \ to \ -60 \ ^{\circ}C < 36 \ min$	Max. Voltage betw	een			
Force-to-Guard 100 V DC 100 V DC 100 V DC Guard-to-GND 400 V DC 400 V DC 400 V DC 400 V DC 400 V DC 400 V DC 400 V DC 25° C -10 to 25^{\circ}C < 3 min	Force-to-GND		600 V DC	600 V DC	600 V DC
Guard-to-GND 400 V DC 400 V DC 400 V DC Heating rates* 25 °C -10 to 25 °C < 3 min	Force-to-Guard		100 V DC	100 V DC	100 V DC
Heating rates* $25 \degree C$ $-10 to 25 \degree C < 3 \min$ $-40 to 25 \degree C < 5 \min$ $-60 to 25 \degree C < 6 \min$ $200 \degree C$ $25 to 200 \degree C < 16 \min$ $25 to 200 \degree C < 28 \min$ $300 \degree C$ $25 to 300 \degree C < 28 \min$ $25 to 300 \degree C < 28 \min$ Cooling rates* AC3 Mode $300 \degree C$ $300 to 25 \degree C < 26 \min$ $200 \degree C$ $200 to 25 \degree C < 26 \min$ $300 to 25 \degree C < 24 \min$ $200 \degree C$ $200 to 25 \degree C < 21 \min$ $200 to 25 \degree C < 22 \min$ $25 \degree C$ $25 to -10 \degree C < 11 \min$ $25 to -40 \degree C < 18 \min$	Guard-to-GND		400 V DC	400 V DC	400 V DC
$\begin{array}{cccccccccccccccccccccccccccccccccccc$	Heating rates*				
200 °C 25 to 200 °C < 16 min	25 °C		-10 to 25 °C < 3 min	-40 to 25 °C < 5 min	-60 to 25 °C < 6 min
300 °C 25 to 300 °C < 28 min Cooling rates* XC3 Mode 300 °C 300 to 25 °C < 26 min 300 to 25 °C < 24 min AC3 Mode 300 °C 200 to 25 °C < 21 min 200 to 25 °C < 22 min 200 to 25 °C < 22 min 25 °C 25 to -10 °C < 11 min 25 to -40 °C < 18 min 25 to -60 °C < 36 min	200 °C			25 to 200 °C < 16 min	
AC3 Mode 300 °C 300 to 25 °C < 26 min	300 °C			25 to 300 °C < 28 min	
AC3 Mode 300 °C 300 to 25 °C < 26 min	Cooling rates*				
200 °C 200 to 25 °C < 21 min 200 to 25 °C < 22 min 25 °C 25 to -10 °C < 11 min	AC3 Mode	300 °C	300 to 25 °C < 26 min	300 to 25 °C	< 24 min
25 °C 25 to -10 °C < 11 min 25 to -40 °C < 18 min 25 to -60 °C < 36 min	200 °C		200 to 25 °C < 21 min	200 to 25 °C	< 22 min
		25 °C	25 to -10 °C < 11 min	25 to -40 °C < 18 min	25 to -60 °C < 36 min
TURBO Mode 300 °C 300 to 25 °C < 26 min 300 to 25 °C < 23 min	TURBO Mode	300 °C	300 to 25 °C < 26 min	300 to 25 °C	< 23 min
200 °C 200 to 25 °C < 21 min 200 to 25 °C < 21 min		200 °C	200 to 25 °C < 21 min	200 to 25 °C	< 21 min
25 °C 25 to -10 °C < 11 min 25 to -40 °C < 16 min 25 to -60 °C < 34 min		25 °C	25 to -10 °C < 11 min	25 to -40 °C < 16 min	25 to -60 °C < 34 min
Leakage@10V N/A N/A N/A	l eakage @ 10 V		N/A	N/A	N/A
Electrical isolation $> 5 T \Omega$ at 25 °C or below > 1 T Ω at 200 °C > 0 5 T Ω at 300 °C	Electrical isolation	1	, >1T	> 5 T Ω at 25 °C or below	°C
Capacitance	Capacitance		· 11		-
Force-to-Guard < 1600 pF < 1600 pF < 1600 nF	Force-to-Guard		< 1600 pF	< 1600 pF	< 1600 pF
Guard-to-Shield < 2000 pF < 2000 pF < 2000 pF	Guard-to-Shield		< 2000 pF	< 2000 pF	< 2000 pF
Typical data for all chucks based on EPS requirements	*Tunical data for all chucks based on EPS requirements				

Specifications of MPI ERS AirCool® PRIME with Fusion Chiller Technology 🌒

		-10 °C to 200/300 °C	-40 °C to 200/300 °C	-60 °C to 200/300 °C	
Chuck type		Ultra low noise	Ultra low noise	Ultra low noise	
Connectivity		Kelvin Triax (f)	Kelvin Triax (f)	Kelvin Triax (f)	
Temperature control	method	Cooling air / Resistance heater	Cooling air / Resistance heater	Cooling air / Resistance heater	
Coolant		Air (user supplied)	Air (user supplied)	Air (user supplied)	
Smallest temperature selection step	2	0.1 °C	0.1 °C	0.1 °C	
Chuck temperature display resolution		0.01 °C	0.01 °C	0.01 °C	
External touchscreen display operation		Yes	Yes	Yes	
Temperature stability	,	±0.08 °C	±0.08 °C	±0.08 °C	
Temperature accuracy	у	0.1 °C	0.1 °C	0.1 °C	
Control method		Low noise DC/PID	Low noise DC/PID	Low noise DC/PID	
Interfaces		RS232C	RS232C	RS232C	
Chuck pinhole surface plating: 200°C / 300°C	e	Nickel / Gold	Nickel / Gold	Nickel / Gold	
SmartVacuum [™] distribution In front for single DUT 5x5 mm (4 holes) and 75 mm (3 in) In center for 150, 200 and 300 mm (6, 8, 12 in)			75 mm (3 in) 3, 12 in)		
Temperature sensor		Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	Pt100 1/3DIN, 4-line wired	
Temperature uniformity		< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	< ±0.5 °C at ≤ 200 °C < ±1 °C at > 200 °C	
Surface flatness and <±12 μm <±		< ±12 μm	< ±12 μm		
Max. Voltage between	ı				
Force-to-GND		600 V DC	600 V DC	600 V DC	
Force-to-Guard		600 V DC	600 V DC	600 V DC	
Guard-to-GND		400 V DC	400 V DC	400 V DC	
Heating rates*					
25 °C		-10 to 25 °C < 3 min	-40 to 25 °C < 5 min	-60 to 25 °C < 6 min	
200 °C		25 to 200 °C < 18 min			
300 °C			25 to 300 °C < 31 min		
Cooling rates*					
AC3 Mode 300 °C 200 °C		300 to 25 °C < 28 min	300 to 25 °C	< 28 min	
		200 to 25 °C < 23 min	200 to 25 °C	< 24 min	
25	°℃	25 to -10 °C < 12 min	25 to -40 °C < 20 min	25 to -60 °C < 40 min	
TURBO Mode 30	0°C	300 to 25 °C < 28 min	300 to 25 °C	< 27 min	
200 °C		200 to 25 °C < 23 min	200 to 25 °C	< 23 min	
25	°C	25 to -10 °C < 12 min	25 to -40 °C < 18 min	25 to -60 °C < 37 min	
Leakage @ 10 V					
-10, -40 or -60 °C		< 30 fA	< 30 fA	< 30 fA	
25 °C		< 15 fA	< 15 fA	< 15 fA	
200 °C		< 30 fA	< 30 fA	< 30 fA	
300 °C		< 50 fA	< 50 fA	< 50 fA	
Capacitance					
Force-to-Guard		< 600 pF	< 600 pF	< 600 pF	
Guard-to-Shield		< 2000 pF	< 2000 pF	< 2000 pF	
*Typical data for all chucks based on FPS requirements.					

HTU Option	-60 °	°C	-50	O°C	-35	°C	0	°C
	typical	max	typical	max	typical	max	typical	max
Accuracy	±0.015	±0.05	±0.015	±0.05	±0.015	±0.05	±0.02	±0.05
Uniformity	±0.4	±0.5	±0.4	±0.5	±0.3	±0.5	±0.15	±0.2
HTU Option		35 °C		50	°C		70 °C	
	typical	ma	ах	typical	max	typ	ical	max
Accuracy	±0.02	±0.	05	±0.02	±0.05	±0.	025	±0.05
Uniformity	±0.08	±0	.1	±0.08	±0.1	±0	.09	±0.1

High Temperature Uniformity Option*

* Only for RF thermal chucks.

THERMAL CHUCKS DIMENSIONS

System Controller / Chiller Dimensions and Power / Air Consumption

System type	W x D x H (mm)	Weight (kg)	Power cons. (VA)	max. Air flow* (l/min)	CDA dew Point
Ambient	300 x 360 x 135	12	1200	400	≤ 0 °C
20 °C, -10 °C to 200 / 300 °C	300 x 360 x 135	12	1200	400	≤ -30 °C
-40 to 200 / 300 °C	420 x 500 x 1020	140	2650	400	≤ -40 °C / -70 °C
-60 to 200 / 300 °C	420 x 500 x 1020	140	2400	450	≤ -40 °C
Electrical primary connection		10	0 to 240 VAC au	to switch	
Electrical frequency			50 Hz / 60	Hz	
Compressed air supply		e	5.0 bar (0.8 MPa	, 87 psi)	



ERS AirCool[®] Fusion*, Controller Integrated Chiller -40 °C / -60 °C



ERS AirCool[®] Fusion*, Controller Integrated Chiller -10 °C

*ERS electronic GmbH patented solution



ERS and MPI's joint product AirCool[®] PRIME Chuck won "Electronics Industry Awards 2018" in the category, "Test, Measurement and Inspection Product of the year".

TYPICAL TRANSITION TIME













SYSTEM CONTROLLER SPECIFICATIONS

CPU	Intel Core i9
RAM	16 GB
64 bit operating system	Windows 11 Enterprise LTSC (English) 64 bit
Storage	500 GB SSD
LAN	1 x internal, 1 x external TCP/IP port
USB Ports	3 x internal, 1 x external
GPIB interface	Optional

SUPPORTED SOFTWARE PLATFORMS

Drivers	WaferPro / IC-CAP & EasyEXPERT from Keysight, BSIMPro & NoisePro from ProPlus, ACS from Keithley
Emulation mode	Available for various prober control software*

* Please contact your local support for more details.

FACILITY REQUIREMENTS

General Probe System

Power	100-240 V AC nominal ; 50/60 Hz
Vacuum	-0.9 bar
Compressed air	6.0 bar

REGULATORY COMPLIANCE

3rd party, TÜV tested according to

IEC 61010-1: 2010 + Am1:2016; EN 61010-1: 2010; IEC/EN 61010-2-010: 2014; IEC/EN 61010-2-081: 2015; EN ISO 12100: 2010; UL 61010-1: 2012/R: 2016-04; UL 61010-2-010: 2015; CAN/CSA-C22.2 No. 61010-1: 2012/U2: 2016-04; CAN/CSA-C22.2 No. 61010-2-010:2015

and certified for CE and US/Canada (NRTL), SEMI S2 and S8. Copies of certificates are available on request

WARRANTY

- Warranty*: 12 months
- Extended service contract: contact MPI Corporation for more information

*See MPI Corporation's Terms and Conditions of Sale for more details.

PHYSICAL DIMENSIONS

TS3500-SE

 System dimensions (W x D x H)
 1400 x 1315 x 1670 mm (55.1 x 51.8 x 65.7 in)

 Weight
 1020 kg

*Can increase depends on operator manual adjustment or interaction.







WaferWallet®

System dimensions (W x D x H)	500 x 1270 x 980 mm (19.7 x 50.0 x 38.6 in)
Weight	180 kg

*Can increase depends on operator manual adjustment or interaction.

TS3500-SE with WaferWallet $^{\circ}$







WaferWallet[®]MAX

 System dimensions (W x D x H)
 530 x 1300 x 980 mm (20.9 x 51.2 x 38.6 in)

 Weight
 200 kg

*Can increase depends on operator manual adjustment or interaction.

TS3500-SE with WaferWallet®MAX







WaferWallet[®]ULTRA

 System dimensions (W x D x H)
 600 x 1660 x 2040 mm (23.6 x 65.4 x 80.3 in)

 Weight*
 328 kg

*Can vary depends on the optional accessories.

TS3500-SE with WaferWallet[®]ULTRA







*Can vary depends on monitor/chiller position.

Direct contact: Asia region: ast-asia@mpi-corporation.com EMEA region: ast-europe@mpi-corporation.com America region: ast-americas@mpi-corporation.com

MPI global presence: for your local support, please find the right contact here: mpi-corporation.com/ast/support/regional-sales-contact

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